



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/643,680
Filing Date August 18, 2003
Inventor Brenda D. Kraus et al.
Assignee Micron Technology, Inc.
Group Art Unit 1762
Examiner Brian K. Talbot
Attorney's Docket No. MI22-2310
Customer No. 021567
Title: Atomic Layer Deposition Methods of Forming Conductive Metal Nitride
Comprising Layers

RESPONSE TO AUGUST 14, 2007 OFFICE ACTION

To: Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

From: Mark Matkin (Tel. 509-624-4276; Fax 509-838-3424)
Wells St. John P.S.
601 West First Avenue, Suite 1300
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Responsive to the Office Action dated August 14, 2007, Applicant
amends and remarks as follows:

AMENDMENTS